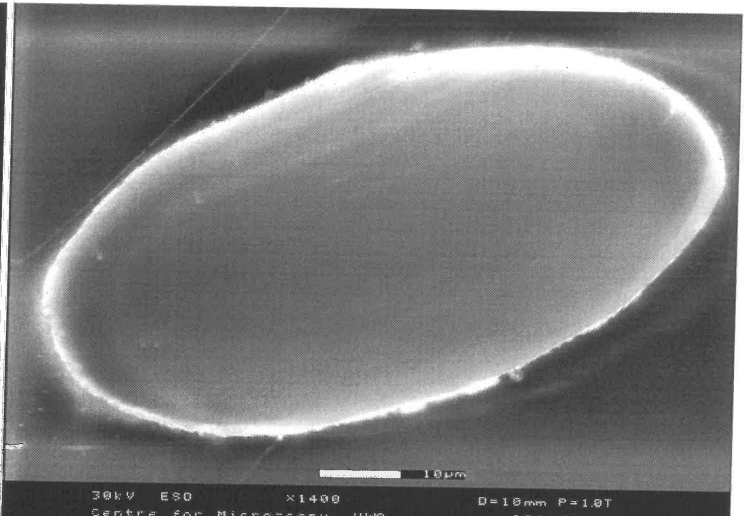
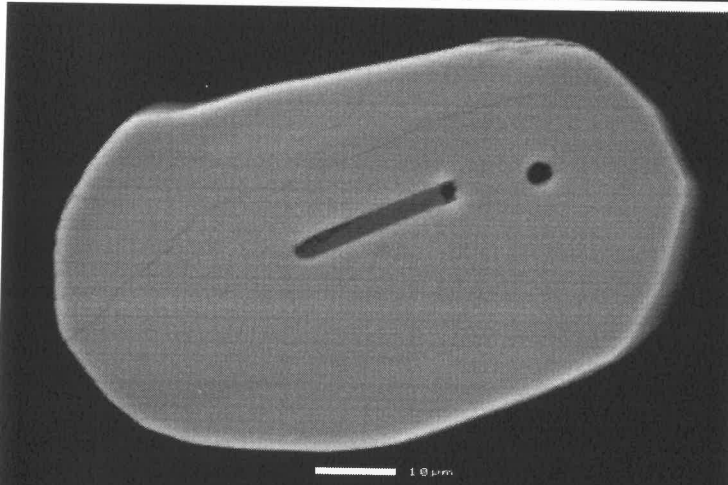


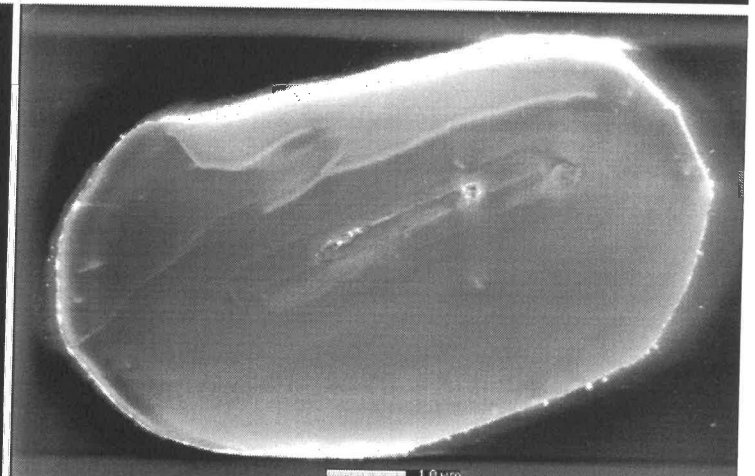
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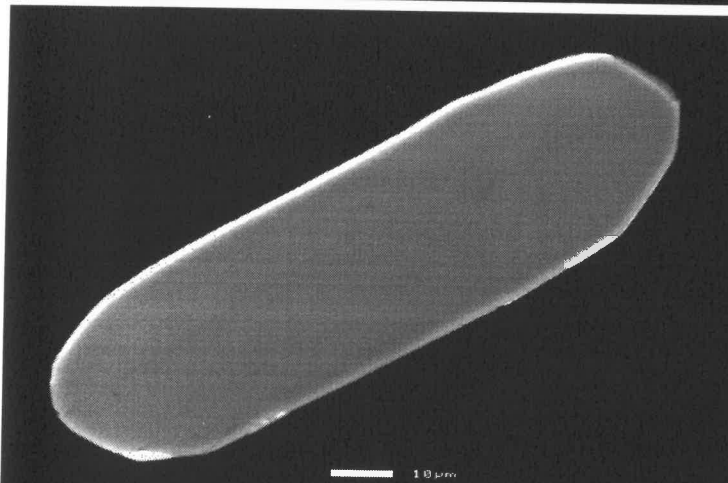
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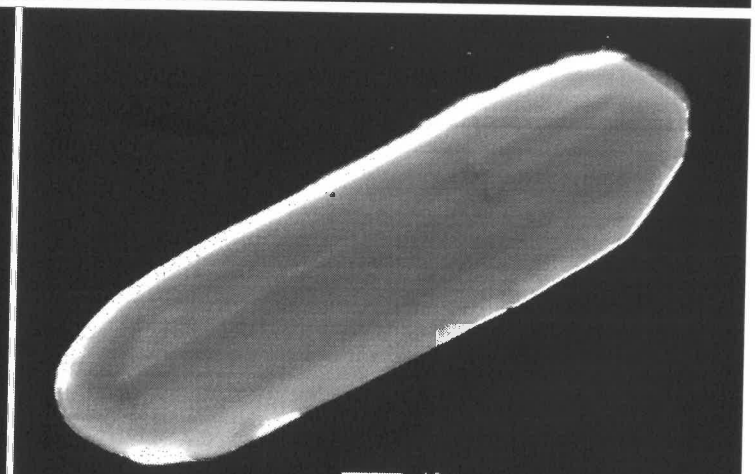
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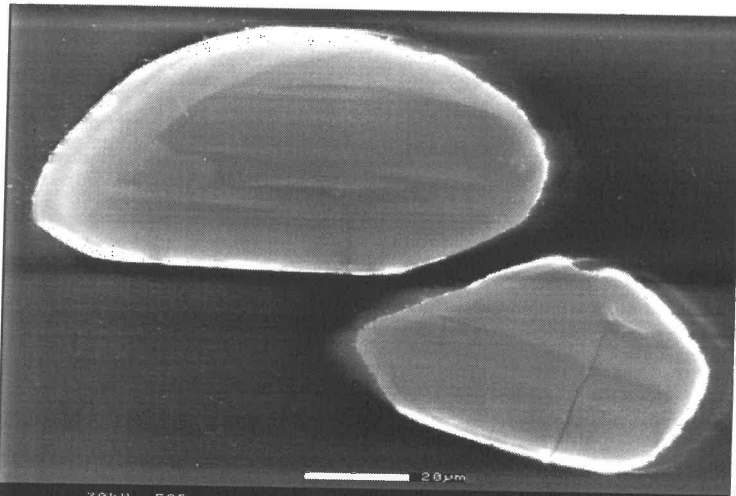
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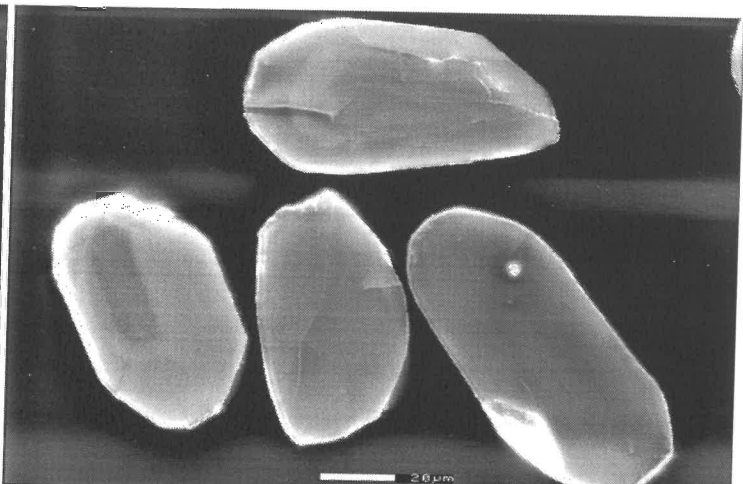


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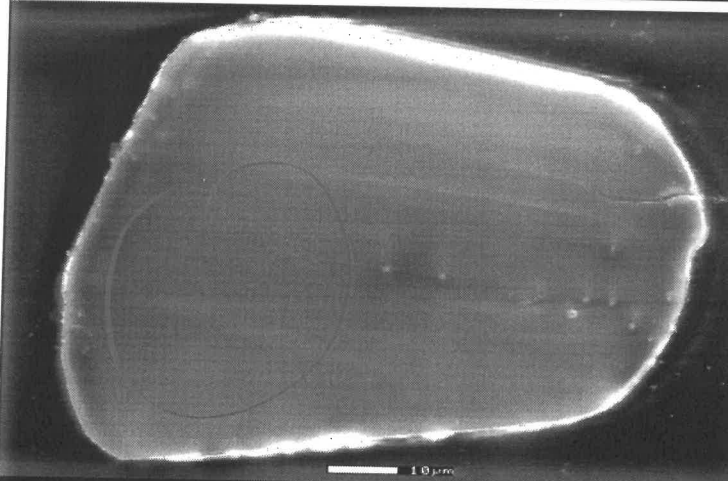
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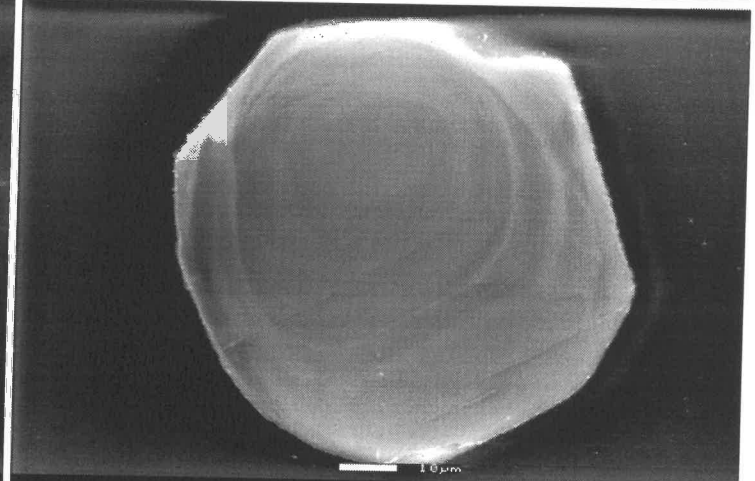
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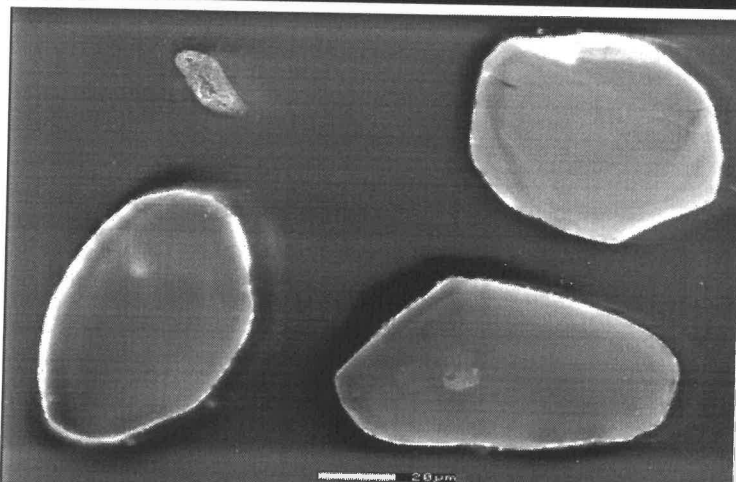
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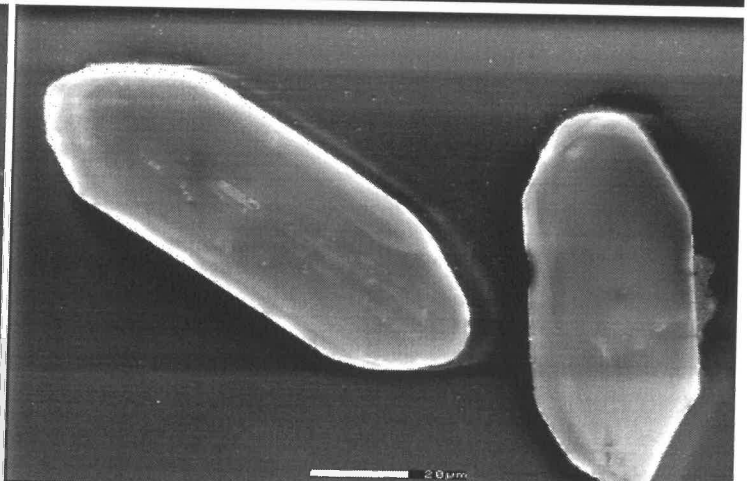
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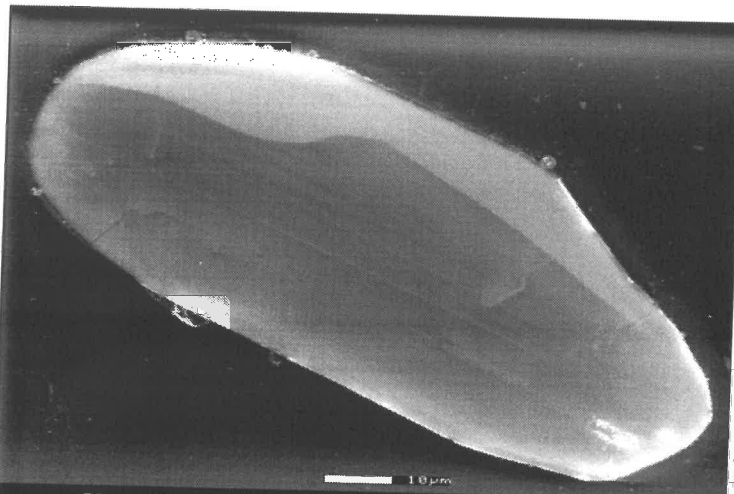
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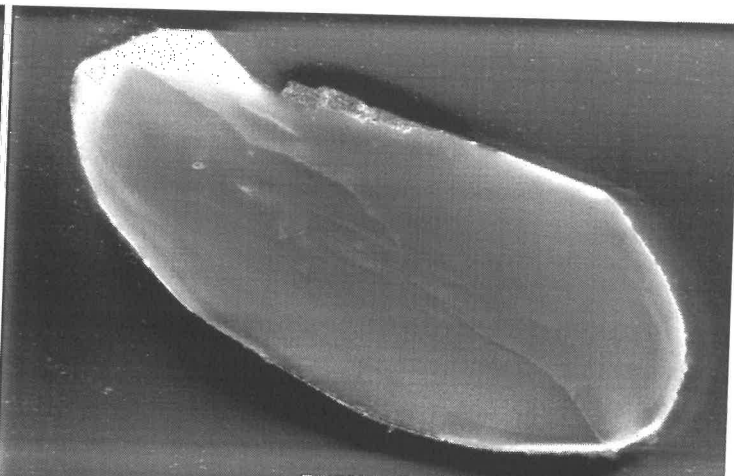
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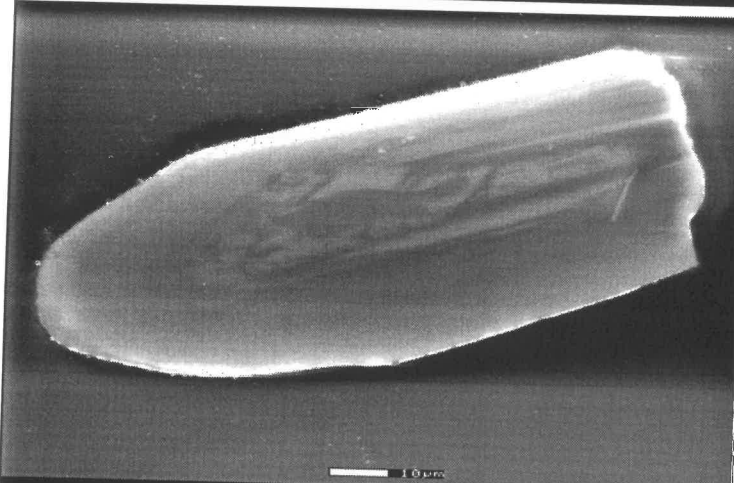
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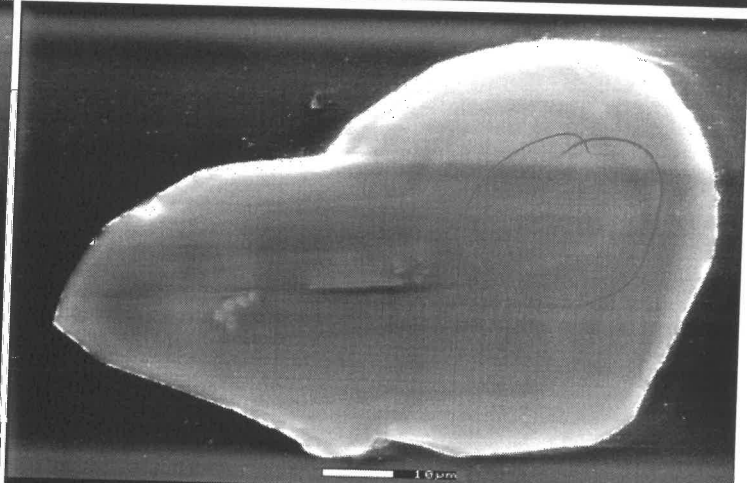
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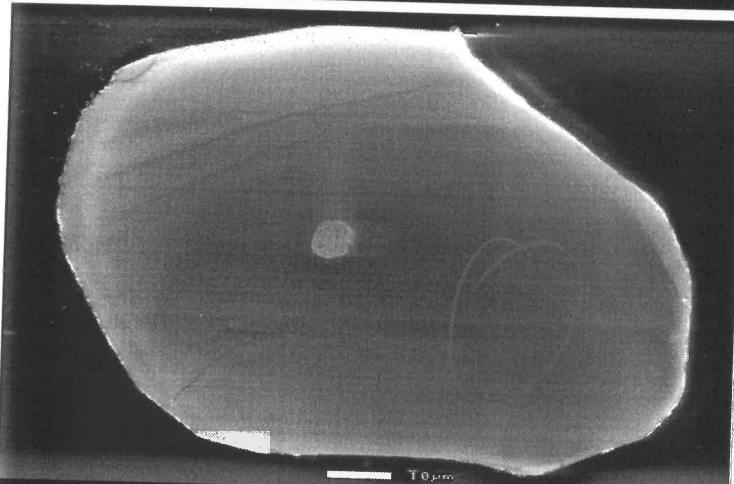
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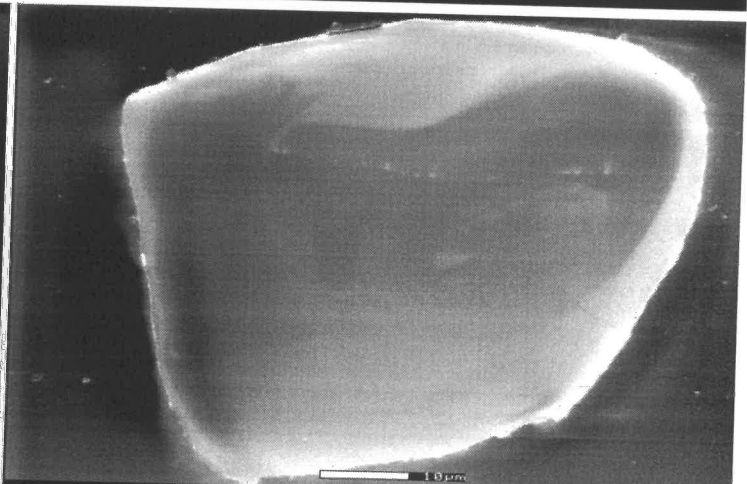
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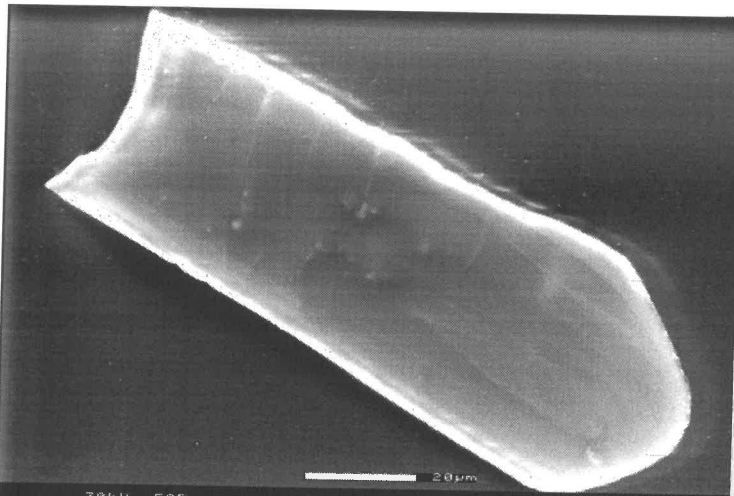
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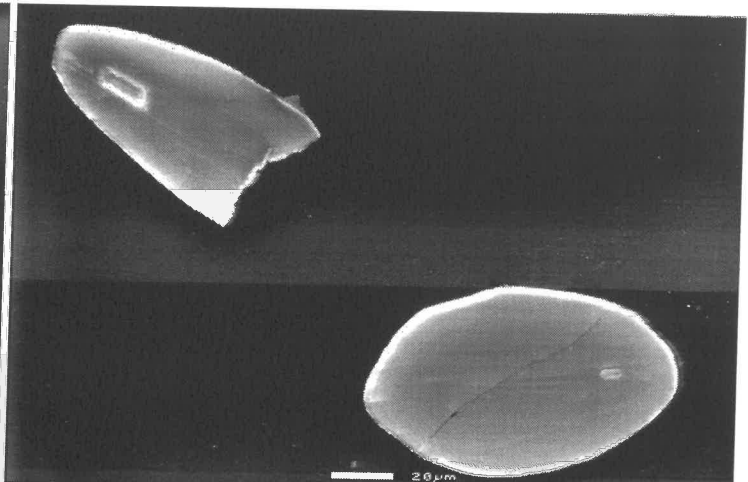
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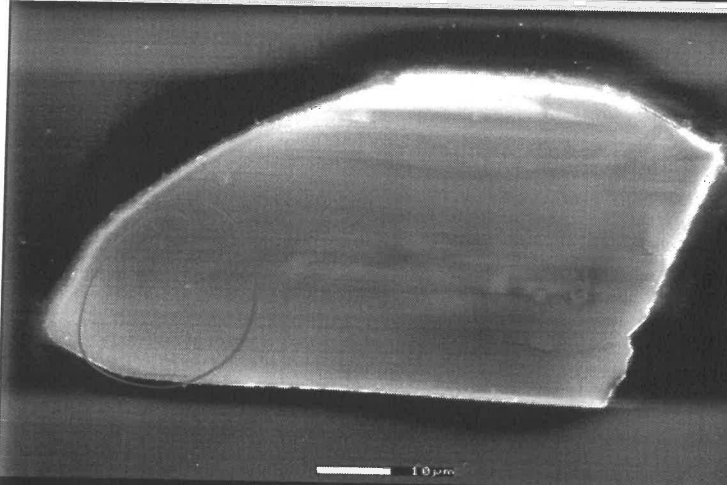
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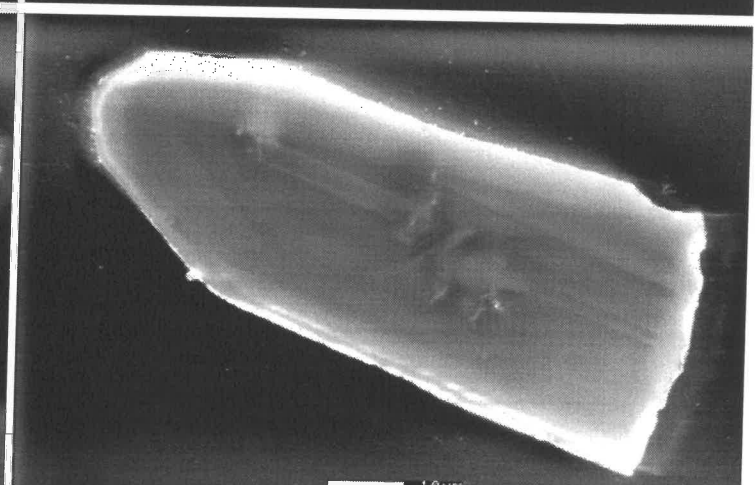
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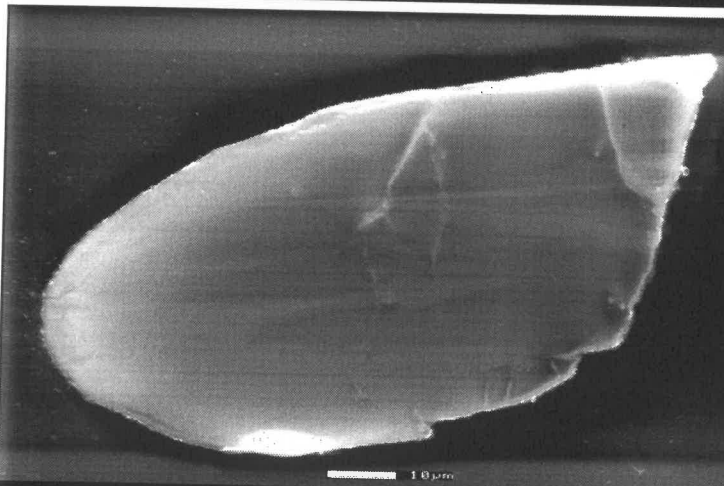
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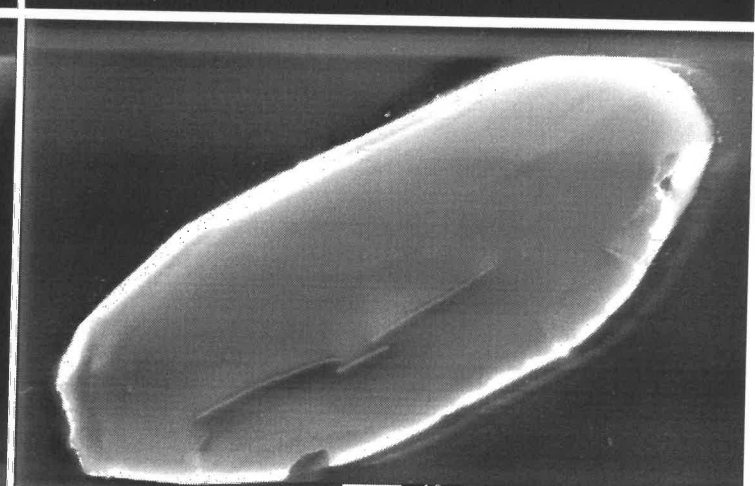
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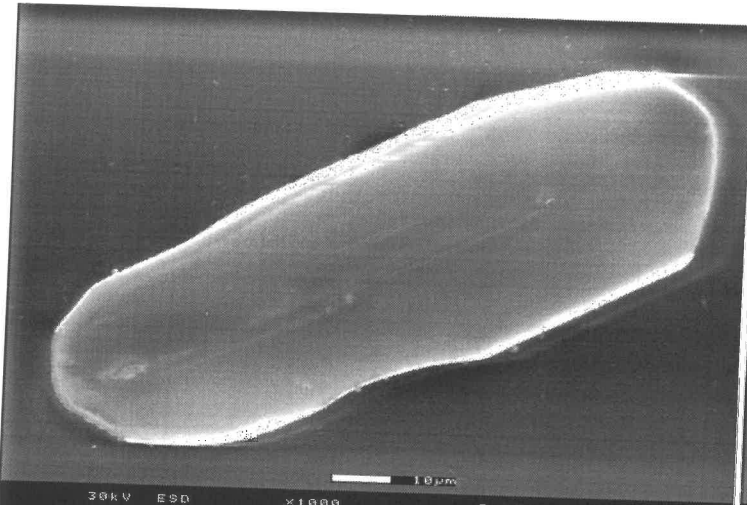
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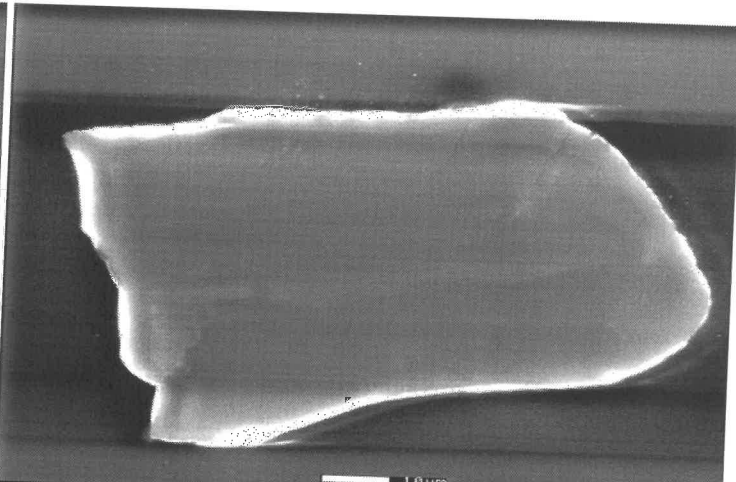
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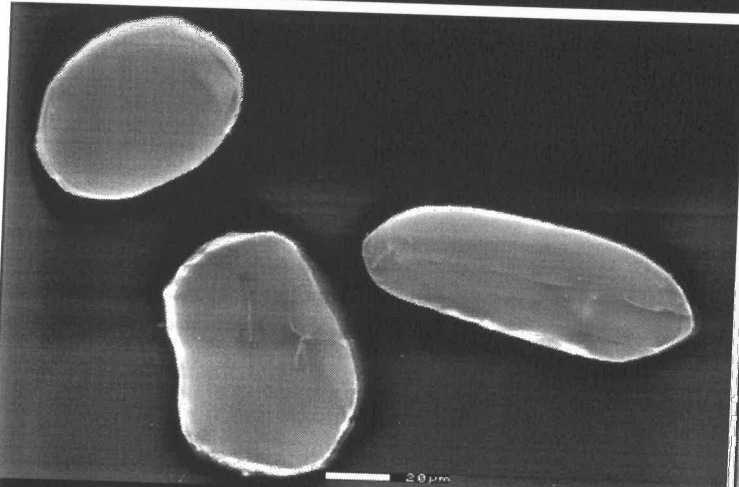
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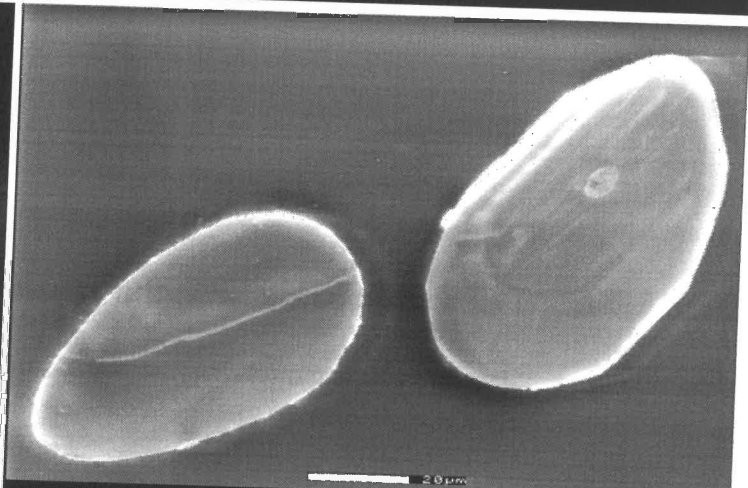
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9889b32s.tif



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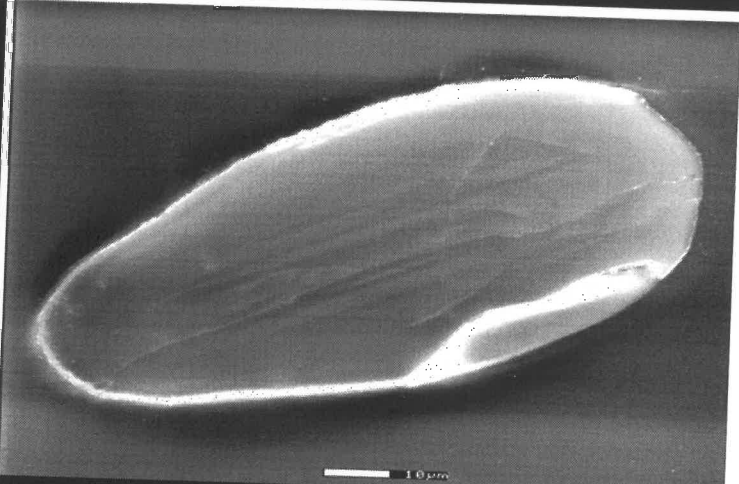
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9889b34s.tif



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9889b35s.tif



30kV ESD X1150  
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